

Application/Control No.	Applicant(s)/Patent und Reexamination	ler
10/647,300	KIM ET AL.	
Examiner	Art Unit	
Cheyne D. Ly	2168	

SEARCHED				
Class	Subclass	Date	Examiner	
707	1 & 3	2/24/2006	. CDL	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
PALM and IFW: Inventor search; EAST and Google: See search history printout.	2/24/2006	CDL
		